

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tadashi Okamoto

Serial No.: 10/518,559

Filed: December 21, 2004

For: Method Of Analyzing Substance On Substrate By Mass Spectrometry

Group Art Unit: 1634

Confirmation No. 8048

Examiner: BHAT, Narayan Kameshwar

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

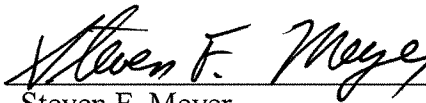
Sir:

In response to the Office Action dated February 21, 2007 constituting a requirement for restriction in the above-identified application, election is made to prosecute the claims in Examiner's Group I, claims 1-15, 24 and 27-38 drawn to method of acquiring data on the mass of a subject fixed on a substrate. This election is made without traverse.

Action on the merits is respectfully requested.

Respectfully submitted,
MORGAN & FINNEGAN, L.L.P.

Dated: March 21, 2007

By: 
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